



In re Application of: KAZUHIRO TANAKA  
 Application No. 09/965,803  
 Filed: October 1, 2001  
 For: METHOD OF CHEMICAL MECHANICAL POLISHING

Mail Stop Non-Fee Amendment  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

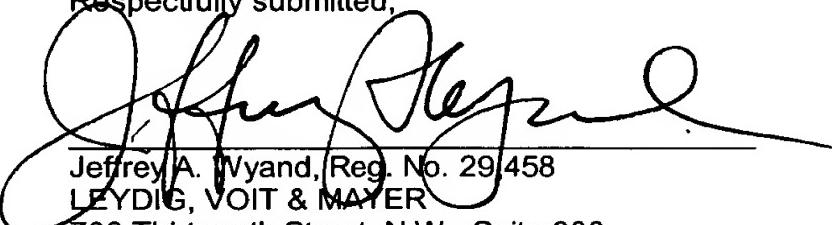
Sir:

- Small entity status is claimed for this application under 37 CFR 1.27.
- Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.
- Other:
- Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

					SMALL ENTITY		OTHER THAN A SMALL ENTITY	
TIME EXTENSION PETITION FEE		none			\$ 0.00	\$ 0.00		
		subtract time extension fee previously paid		none	(\$ 0.00)	(\$ 0.00)		
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADDT. CLAIM FEE	RATE	ADDT. CLAIM FEE
TOTAL		MINUS		=0	x 9=	\$	x 18=	\$
INDEPENDENT		MINUS		=0	x 43=	\$	x 86=	\$
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM				+ 145=	\$	+ 290=	\$
<b>TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT</b>					<b>TOTAL</b>	<b>\$</b>	<b>TOTAL</b>	<b>\$</b>

- The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.
- Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
- Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

  
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Date: February 4, 2004  
 JAW:ves



PATENT  
Attorney Docket No. 401384

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

KAZUHIRO TANAKA

Application No. 09/965,803

Art Unit: 1763

Examiner: R. Culbert

Filed: October 1, 2001

For: **METHOD OF CHEMICAL  
MECHANICAL POLISHING**

**RESPONSE TO OFFICE ACTION**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated November 6, 2003, please enter the following amendments and consider the following remarks.